

Expedited procedure
Under 37 CFR 1.116



1204.41259X00

AF/8
OC
DFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. UCHIDA, et al.
Serial No. 10/069,404
Filed: MAY 6, 2002
For: POLISHING MEDIUM FOR CHEMICAL-MECHANICAL
POLISHING, AND POLISHING METHOD
Group AU: 1765
Examiner: Lynette T. Umez Eronini
Confirm. No: 3597

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF – FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 27, 2006

Sir:

In response to the Office Action mailed March 27, 2006, please amend the
above-identified application as listed in the following, and as set forth on the
following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.